

Form PTO-1449

**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**

(Use several sheets if necessary)

ATTY DOCKET NO.
32860-000901/USAPPLICATION NO.
NEW APPLICATIONAPPLICANT(S)
Dr. Walter GUMBRECHT et al.CONF. NO.
UnknownFILING DATE
June 20, 2005GROUP
Unknown**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
/L.E./	US 2004/063152 A1	04-01-2004	GUMBRECHT et al.			
/L.E./	US 2002/0028441 A1	03-07-2004	HINTSCHE et al.			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
						YES	NO
/L.E./	WO 00/62047	10-19-2000	WIPO			Abstract	
/L.E./	WO 9012314	10-18-1990	WIPO			Abstract	
/L.E./	WO 00/63682	10-26-2000	WIPO			X	
/L.E./	WO 0242759 A1	05-30-2002	WIPO			Abstract	
/L.E./	DE 19610115	09-18-1997	GERMANY			Abstract	
/L.E./	DE 10015816	10-18-2001	GERMANY			Abstract	
/L.E./	WO 98/19153	05-07-1998	WIPO			X	

OTHER DOCUMENTS (Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.

/L.E./		M. Paeschke et al.: Voltammetric Multichannel Measurements Using Silicon Fabricated Microelectrode Arrays, Electroanalysis 8, No. 10, S. 891-899, 1996
/L.E./		R. Hintsche et al.: Microbiosensors Using electrodes Made in Si-Technology, Frontiers in Biosensorics, Fundamental Aspects, edited by F.W. Scheller et al., Dirk Hauser Verlag, Basel, S. 267-283, 1997
/L.E./		German Translation Aid Date Unknown
/L.E./		German Office Action Dated 03-24-2005
/L.E./		International Search Reports (English and German) dated 05-05-2004

EXAMINER

/Lydia Edwards/

DATE CONSIDERED

12/05/2007

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

DJD/let